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PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

JCS/JSP

APPL NUM 10008665	FILING DATE 11/03/2001	CLASS 427	SUBCLASS 1702	GAU 1702	EXAMINER J. A. Miller
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\*\*APPLICANTS: Alling Eric; Bayes Martin;

\*\*CONTINUING DATA VERIFIED:  
THIS APPLN CLAIMS BENEFIT OF 60/245,937 11/03/2000

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\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no
Verified and Acknowledged Examiners's initials		
TITLE : Electrochemical co-deposition of metals for electronic device manufacture		
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL		Primary Examiner		
DISCLAIMER		PREPARED FOR ISSUE		
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